

## MWIR continuous zoom optical system with magnification of 45

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**Abstract:** The MWIR continuous zoom optical system has many advantages. A method for designing the system with large zoom range was introduced. Then, a system with 8 lenses was designed. The system works in the wavelength range of 3.7~4.8  $\mu\text{m}$  with 10~450 mm continuous zoom, and the MTF value in Nyquist limit (16 lp/mm) is more than 0.3 over the full range. The F/number of the system is 4. It can satisfy 100% cold shield efficiency.

**Key words:** MWIR; continuous zoom; large zoom range; optical design

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### 45倍中波红外连续变焦光学系统

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**摘要:** 红外连续变焦光学系统具有很多优势, 介绍了一种可以实现高变焦比的设计方法. 据此设计了一个系统, 其由八片透镜组成, 工作波段为 3.7~4.8  $\mu\text{m}$ , 可实现 10~450 mm 连续变焦. 系统在全焦距范围内奈奎斯特频率处的 MTF 值均大于 0.3, 系统 F 数为 4, 且满足冷光阑效率 100% 的要求.

**关键词:** 中波红外; 连续变焦; 高变焦比; 光学设计

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### Introduction

There are lots of advantages about infrared imaging technology. Infrared optical systems are used in many applications. Continuous zoom optical system has a continuous change in the field of view, searching target in wide field of view while observing target in narrow field of view<sup>[1-3]</sup>. The demand of infrared continuous zoom optical system increases, especially for those with large zoom range. Large zoom range means that the system has a greater range of search and a higher accuracy of

observation, and so there is great significance in design of infrared continuous zoom system with large zoom range. There are two types of zoom systems, optically compensated and mechanically compensated. Almost all infrared zoom systems are mechanically compensated<sup>[4]</sup>. In a traditional mechanically compensated zoom system, one element move for changes in focal length, while the other one move to eliminate image shift, as shown in Fig. 1. Using traditional mechanically compensated type, MWIR zoom systems can not achieve a large zoom range (such as 45)<sup>[1-3, 5-9]</sup>.

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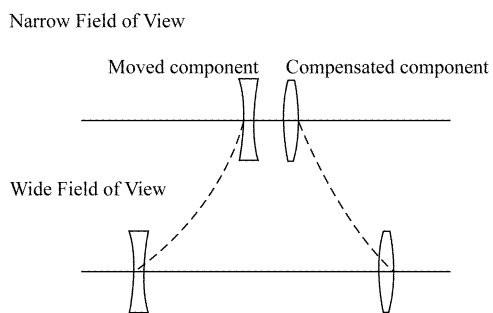


Fig. 1 Traditional mechanically compensated type  
图 1 传统机械变焦类型

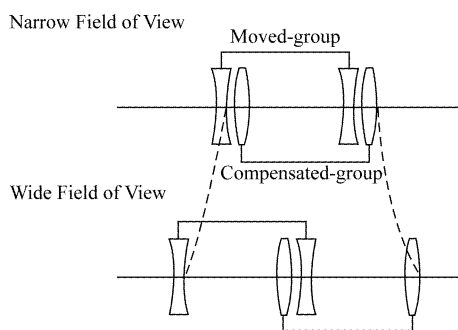


Fig. 2 New mechanically compensated type  
图 2 新型机械变焦类型

In this paper, the new mechanically compensated type for continuous zoom system with large zoom range is introduced. In the zoom system, two elements move together for changes in focal length, while two other elements move together to eliminate image shift, as shown in Fig. 2. Especially, the system works with cooled FPA detector. Then a MWIR continuous zoom system was designed. It can realize continuous zoom of 10 ~ 450 mm.

## 1 Principles

Figure 3 presents schematic of the zoom optical system. In the system, by moving moved components (constituted of  $M_1$  and  $M_2$ ) and compensated components (constituted of  $C_1$  and  $C_2$ ), the field of view can be changed continuously. During the process of zooming, elements  $X_1$ ,  $X_2$  and  $R$  are all stable.  $I_1$  is the position of the image focal point of element  $X_1$ ,  $I_5$  is the position of the image plane of the system.

### 1.1 Zoom

Figure 4 presents the zoom part of the system composed of thin lenses.  $H_1$  is the position of the primary

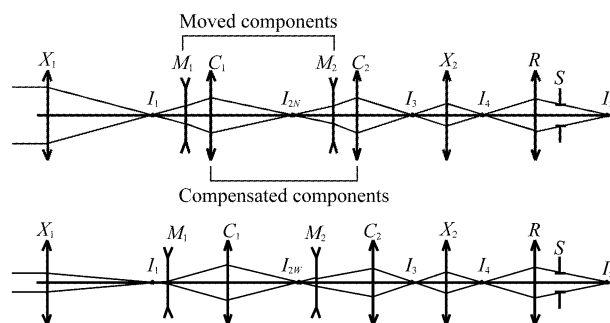


Fig. 3 Schematic of the zoom system  
图 3 变焦系统原理图

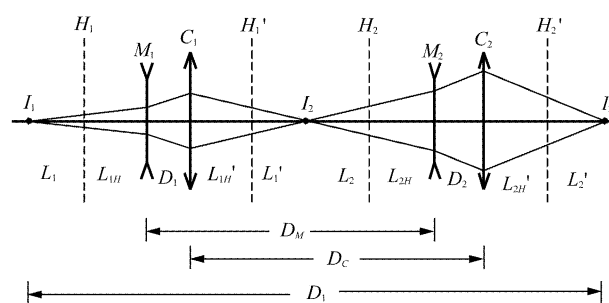


Fig. 4 Scheme of the zoom part  
图 4 光学系统变焦部分

principal plane of the two elements  $M_1$  and  $C_1$ ,  $H_1'$  is the position of the secondary principal plane of the two elements  $M_1$  and  $C_1$ .  $H_2$  is the position of the primary principal plane of the two elements  $M_2$  and  $C_2$ ,  $H_2'$  is the position of the secondary principal plane of the two elements  $M_2$  and  $C_2$ .  $I_2$  is the image of the point  $I_1$ ,  $I_3$  is the image of the point  $I_2$ .  $D_M$  is the distance of  $M_1$  from  $M_2$ ,  $D_C$  is the distance of  $C_1$  from  $C_2$ ,  $D_1$  is the distance of  $I_1$  from  $I_3$ . The distances are given by relations,

$$D_M = D_1 + L_{1H'} + L_1' - L_2 - L_{2H} \quad , \quad (1)$$

$$D_C = -D_1 + D_M + D_2 \quad , \quad (2)$$

$$D_1 = -L_1 - L_{1H} + D_M + D_2 + L_{2H'} + L_2' \quad , \quad (3)$$

where  $-L_1$  is the distance of  $I_1$  from  $H_1$ ,  $-L_{1H}$  is the distance of  $H_1$  from  $M_1$ ,  $D_1$  is the distance of  $M_1$  from  $C_1$ ,  $L_{1H'}$  is the distance of  $C_1$  from  $H_1'$ ,  $L_1'$  is the distance of  $H_1'$  from  $I_2$ ,  $-L_2$  is the distance of  $I_2$  from  $H_2$ ,  $-L_{2H}$  is the distance of  $H_2$  from  $M_2$ ,  $D_2$  is the distance of  $M_2$  from  $C_2$ ,  $L_{2H'}$  is the distance of  $C_2$  from  $H_2'$ ,  $L_2'$  is the distance of  $H_2'$  from  $I_3$ . As it is well known<sup>[10]</sup>, the following relations hold for

imaging,

$$D_1 = F_{M_1} + F_{C_1} - \frac{F_{M_1} \cdot F_{C_1}}{F_1}, L_{1H} = \left( \frac{F_{M_1}}{F_{C_1}} + 1 \right) \cdot$$

$$F_1 - F_{M_1}, L_{1H}' = - \left( \frac{F_{C_1}}{F_{M_1}} + 1 \right) \cdot F_1 + F_{C_1},$$

$$D_2 = F_{M_2} + F_{C_2} - \frac{F_{M_2} \cdot F_{C_2}}{F_2}, L_{2H} = \left( \frac{F_{M_2}}{F_{C_2}} + 1 \right) \cdot$$

$$F_2 - F_{M_2}, L_{2H}' = - \left( \frac{F_{C_2}}{F_{M_2}} + 1 \right) \cdot F_2 + F_{C_2},$$

$$L_1 = \left( \frac{1}{\beta_1} - 1 \right) \cdot F_1, L_1' = (1 - \beta_1) \cdot F_1,$$

$$L_2 = \left( \frac{1}{\beta_2} - 1 \right) \cdot F_2, L_2' = (1 - \beta_2) \cdot F_2, (4)$$

where  $F_{M_1}$  is the focal length of  $M_1$ ,  $F_{C_1}$  is the focal length of  $C_1$ ,  $F_1$  is the focal length of the two elements  $M_1$  and  $C_1$ ,  $\beta_1$  is the magnification of the two elements  $M_1$  and  $C_1$ ,  $F_{M_2}$  is the focal length of  $M_2$ ,  $F_{C_2}$  is the focal length of  $C_2$ ,  $F_2$  is the focal length of the two elements  $M_2$  and  $C_2$ ,  $\beta_2$  is the magnification of the two elements  $M_2$  and  $C_2$ .  $T$  is the magnification of the zoom part (elements  $M_1$ ,  $C_1$ ,  $M_2$  and  $C_2$ ). From equations (1) ~ (4), we obtain:

$$\frac{F_{C_1}}{F_{M_1}} \cdot F_1 + \frac{F_{M_2}}{F_{C_2}} \cdot F_2 + \beta_1 \cdot F_1 + \frac{F_2}{\beta_2} + \frac{F_{M_1} \cdot F_{C_1}}{F_1} +$$

$$D_M - 2F_{C_1} - F_{M_1} - F_{M_2} = 0, (5)$$

$$\frac{F_{M_1} \cdot F_{C_1}}{F_1} - \frac{F_{M_2} \cdot F_{C_2}}{F_2} + D_M - D_C - F_{M_1} - F_{C_1} +$$

$$F_{M_2} + F_{C_2} = 0, (6)$$

$$\frac{F_{C_2}}{F_{M_2}} \cdot F_2 + \frac{F_{M_1}}{F_{C_1}} \cdot F_1 + \beta_2 \cdot F_2 + \frac{F_1}{\beta_1} + \frac{F_{M_2} \cdot F_{C_2}}{F_2} +$$

$$D_1 - D_M - 2F_{C_2} - F_{M_1} - F_{M_2} = 0, (7)$$

$$T = \beta_1 \cdot \beta_2. (8)$$

The values  $D_1$ ,  $D_M$ ,  $D_C$ ,  $F_{M_1}$ ,  $F_{C_1}$ ,  $F_{M_2}$ ,  $F_{C_2}$  and  $T$  are parameters, which can be chosen appropriately. By solving equations (5) ~ (8) we can determine the values  $F_1$ ,  $F_2$ ,  $\beta_1$  and  $\beta_2$ . Then, there is one configuration of the zoom part composed of thin lenses. With different value  $T$ , we can obtain different configuration.

## 1.2 Re-imaging

Figure 5 presents the re-imaging part of the system composed of thin lenses.  $E$  is the exit pupil of the system (constituted of  $X_1$ ,  $M_1$ ,  $C_1$ ,  $M_2$ ,  $C_2$  and  $X_2$ ),  $S$  is the cold stop of the detector. In order to satisfy 100% cold shield efficiency, the stop of the zoom opti-

cal system should be coincided with  $S$ .  $I_4$  is the image of the point  $I_3$ .  $F_R$  is the focal length of the re-imaging part  $R$ . Imaging are given by relations,

$$\frac{1}{L_R' - D_S} - \frac{1}{L_R - D_E} = \frac{1}{F_R}, (9)$$

$$\frac{1}{L_R'} - \frac{1}{L_R} = \frac{1}{F_R}, (10)$$

$$\frac{L_R'}{L_R} = \beta_R, (11)$$

where  $D_E$  is the distance of  $E$  from  $I_4$ ,  $-L_R$  is the distance of  $I_4$  from  $R$ ,  $L_R'$  is the distance of  $R$  from  $I_5$ ,  $D_S$  is the distance of  $S$  from  $I_5$ ,  $\beta_R$  is the magnification of the re-imaging part  $R$ . The values  $D_E$ ,  $D_S$  and  $\beta_R$  are parameters, which can be chosen appropriately. By solving equations (9) ~ (11) we can determine the values  $F_R$ ,  $L_R'$  and  $L_R$ . Then, there is the configuration of the re-imaging part.

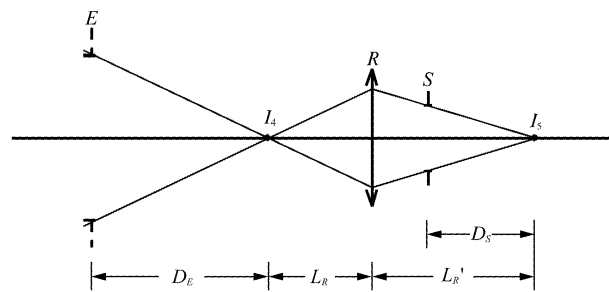


Fig. 5 Scheme of the re-imaging part

图5 光学系统二次成像部分

## 2 Designs

### 2.1 Parameters

The zoom system is with a  $320 \times 240$  staring focal plane array. The dimension of detector pixel is  $30 \mu\text{m} \times 30 \mu\text{m}$ . The characteristics of the system are shown in Table 1.

Table 1 Characteristics of the system

表1 系统设计指标

Parameter	Value
Focal Length Range	10 ~ 450 mm
Zoom Range	45
F/number	4
Spectral Band	3.7 ~ 4.8 $\mu\text{m}$
Field of View	1.53° ~ 61.92°
Operational Temperature Range	-20 ~ 50 °C

## 2.2 Results

The zoom system was made of materials of silicon and germanium. The overall length of the system is 400 mm. In the zoom system, there are 8 lenses including 4 aspheric surfaces. Structure of the system is shown in Fig. 6. During the process of zooming, the 2nd lens and the 4th lens move together, and the 3rd lens and 5th lens also move together. Both of the paths are smooth. The zoom system satisfies 100% cold shield efficiency.

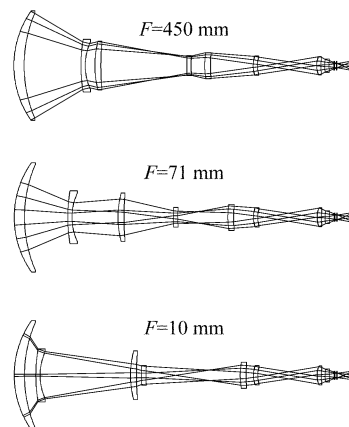


Fig. 6 Structure of the zoom system  
图 6 变焦系统结构图

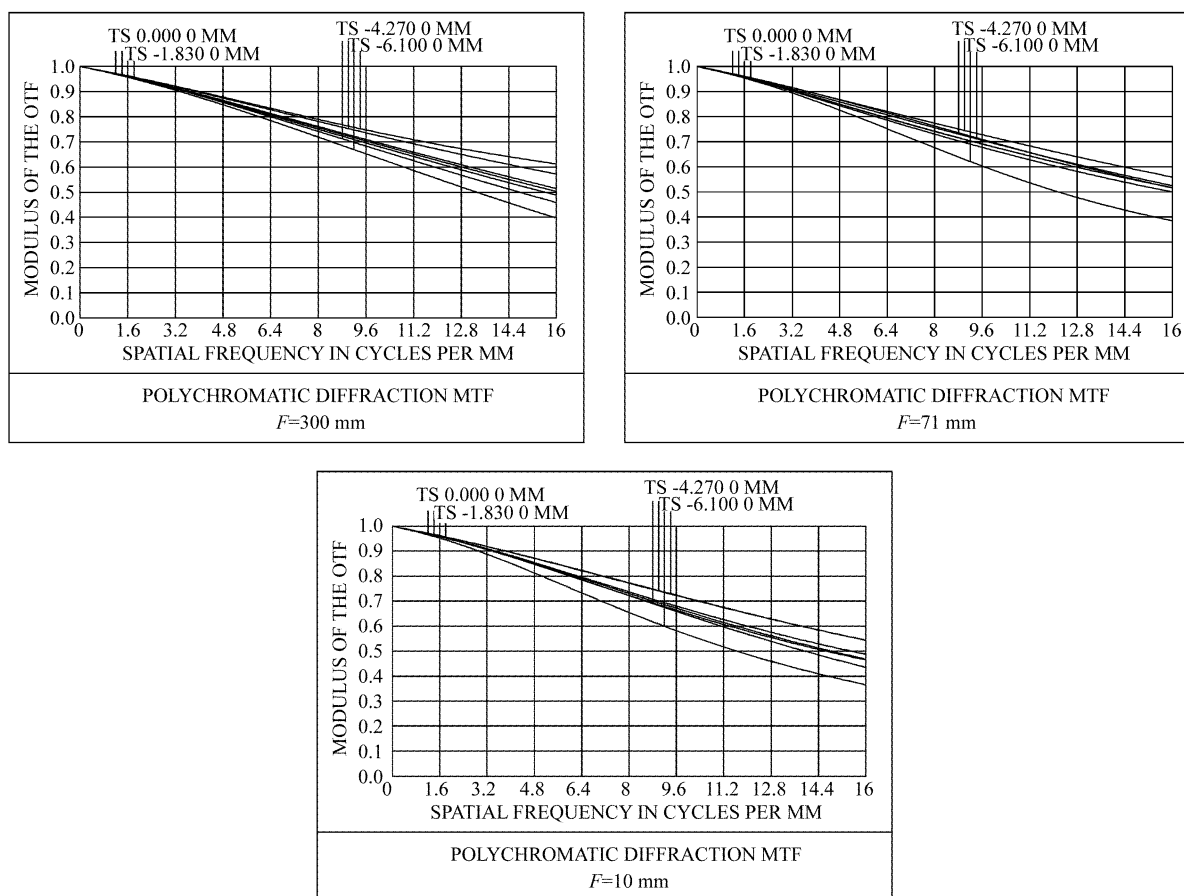


Fig. 7 MTF curves of the system  
图 7 系统调制传递函数图

## 2.3 Performance

Figure 7 illustrates MTF performances for the three different zoom positions in 20 °C. MTF values in Nyquist limit (16 lp/mm) are more than 0.3 over the full range. It was found out that the zoom system is with high image quality. Operational temperature range

of the system is  $-20 \sim 50$  °C, we need to achieve a thermalisation by some active means, involving temperature measurement and control of the axial position of the detector.

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simulated S-parameters under all investigated bias conditions. In addition, the proposed method has been confirmed by the intrinsic elements, which agrees with the theoretical expectations.

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### 3 Conclusions

Principles of the continuous zoom system with large zoom range are introduced. A MWIR continuous zoom system with 320 × 240 staring FPA was designed, which can realize zoom range of 45. The system has high image quality and satisfies 100% cold shield efficiency. MWIR continuous zoom system with large zoom range has an enormous potential for many applications such as tracking and surveillance.

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